

<b>Notice of References Cited</b>	Application/Control No. 10/665,496	Applicant(s)/Patent Under Reexamination WEI ET AL.	
	Examiner Michael Cleveland	Art Unit 1762	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-3,963,630	06-1976	Yonezawa et al.	252/62.9PZ
*	B	US-5,069,744	12-1991	Borodin et al.	117/71
*	C	US-5,790,368	08-1998	Naito et al.	361/523
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	N. Ishizawa et al., "Preparation of BaTiO <sub>3</sub> and SrTiO <sub>3</sub> Polycrystalline Thin Films on Flexible Polymer Film Substrate by Hydrothermal Method", Jpn. J. Appl. Phys., 29, 2467-2472 (Nov. 1990).
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.